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U.S. UTILITY Patent Application

P

PATENT NUMBER and
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10079775	02/19/2002	438		2823	H Lee

**APPLICANTS: Plat Marina; Hui Angela;

**CONTINUING DATA VERIFIED: 09/433,531 11/2/1999
THIS APPLICATION IS A DIV OF 09/433,541 11/03/1999

(*) Data inconsistent with PTO records.

Yes

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** FOREIGN APPLICATIONS VERIFIED:

NONE

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO
35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	D900D/1368D
Verified and Acknowledged Examiners's initials Lee		
TITLE : Method and system for reducing ARC layer removal during removal of photoresist		

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner PREPARED FOR ISSUE WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.	

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